

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Number : 10/706,266  
Applicant : SHOTA et al.  
Filed : November 13, 2003  
Tech Center/AU : 1722  
Examiner : Kunemund, Robert M.  
Entitled : SILICON WAFER AND MANUFACTURING METHOD  
THEREOF  
Attorney Reference : 061063-0306825  
Customer Number : 00909

Confirmation No. 5650

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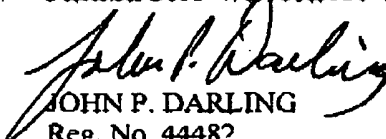
**CERTIFICATION OF FACSIMILE TRANSMISSION**  
**UNDER 37 C.F.R. §1.8**

I hereby certify that the following papers are being transmitted by facsimile to Examiner Robert M. Kunemund at the U.S. Patent and Trademark Office at 571-273-8300 on the date shown below:

- Transmittal
- Amendment
- PTO-1449
- November 13, 2003 Post Card Receipt

Respectfully submitted,

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Date: July 20, 2005

TOTAL NUMBER OF PAGES IN FACSIMILE: 16

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**JUL 20 2005**

Attorney's Docket: 061063-0306825  
 Client Reference: OSP-15115

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re PATENT APPLICATION of:  
 SHIOTA et al.

Confirmation Number: 5650

Application No.: 10/706,266

Group Art Unit: 1722

Filed: November 13, 2003

Examiner: Kunemund, Robert M.

For: SILICON WAFER AND MANUFACTURING METHOD THEREOF

Commissioner for Patents  
 P.O. Box 1450  
 Alexandria, VA 22313-1450

**AMENDMENT/RESPONSE TRANSMITTAL**

Transmitted herewith is an amendment/response for this application.

**EXTENSION OF TIME**

The proceedings herein are for a patent application and the provisions of 37 C.F.R. 1.136 apply. Applicant petitions for a 1 month extension of time under 37 C.F.R. 1.136.

**FEES**

The fee for claims and extension of time (37 C.F.R. 1.16 and 1.17) has been calculated as shown below:

	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDIT. FEE
TOTAL	28	- 24	= 4	x \$ 50.00	= \$ 200.00
INDEP.	1	- 3	= 0	x \$ 200.00	= \$ 0.00
FIRST PRESENTATION OF MULTIPLE DEP. CLAIM				+ \$ 360.00	= \$ 0.00
TOTAL ADDITIONAL CLAIM FEE					\$ 200.00
EXTENSION OF TIME FEE					\$ 120.00
GRAND TOTAL					\$ 320.00

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SHIOTA et al. - - 10/706,266  
Attorney's Docket: 061063-0306825

**FEE PAYMENT**

Authorization is hereby made to charge the amount of \$320.00 to Deposit Account No. 033975. Charge any additional fees required by this paper or credit any overpayment in the manner authorized above. A duplicate of this paper is attached.

Date: July 20, 2005

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**JUL 20 2005**

Attorney Docket: 061063-0306825  
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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re PATENT APPLICATION of:  
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Application No.: 10/706,266

Filed: November 13, 2003

Examiner: Kunemund, Robert M.

Title: SILICON WAFER AND MANUFACTURING METHOD THEREOF

**AMENDMENT UNDER 37 C.F.R. §1.111**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the Office Action dated March 25, 2005, the period for reply being extended by the Petition for One-Month Extension of Time filed herewith, please amend the above-identified application as follows:

07/21/2005 SSITHIB1 00000088 033975 10706266

01 FC:1251 120.00 DA

07/21/2005 SSITHIB1 00000088 033975 10706266

02 FC:1202 200.00 DA